



Attorney Docket No. 09799940-0120

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
BEFORE THE BOARD OF PATENT APPEALS AND INTERFERENCES

PATENT  
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OCT 24 2003  
TC 1700

In re Patent Application of:

**Thinghao F. Wang**

Application No. 10/071,809

Filed: **February 7, 2002**

For: **METHOD FOR SELECTIVELY  
ETCHING SILICON AND/OR  
METAL SILICIDE**

) Group Art Unit: 1765

) Examiner: **Deo, Duy Vu**

) **Certificate of Mailing (37 CFR 1.8(a))**  
) I hereby certify that this paper (along with  
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) or enclosed) is being deposited with the  
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) Alexandria, VA 22313-1450, on:

)   
) Paul E. Rauch, Ph.D.

) Date

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**NOTICE OF APPEAL**

Dear Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the decision of the Examiner dated May 16, 2003, finally rejecting claims 1, 3-12, 14, 15, 21-23, 25, 27. Pursuant to 37 C.F.R. § 1.17(b), the fee for this Notice of Appeal is \$330.00. PTO Form 2038 is enclosed to cover the required fees.

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 19-3140. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

Dated: October 16, 2003

By: 

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